



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

ENSINGER et al

Application No: 10/814,590

Filed: April 1, 2004

Group: 3723

For: RETAINING RING FOR HOLDING
SEMICONDUCTOR WAFERS IN A
CHEMICAL MECHANICAL
POLISHING APPARATUS

STATUS INQUIRY

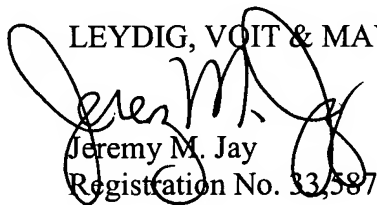
Commissioner of Patents
U. S. Patent and Trademark Office
Randolph Building
401 Dulany Street, Mail Stop
Alexandria, VA 22314

Dear Sir:

Please furnish us the status of the above-noted patent application. It has been eighteen months since the application was filed and as of today our office has no record of receiving an action.

Respectfully submitted,

LEYDIG, VOIT & MAYER


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JMJ:cl 403033